

Abstract Submitted  
for the MAR08 Meeting of  
The American Physical Society

**Oxygen-Induced Reconstructions on the  $\beta$ -Si<sub>3</sub>N<sub>4</sub> (10 $\bar{1}$ 0) Surfaces**  
WERONIKA WALKOSZ, JUAN CARLOS IDROBO, SERDAR OGUT<sup>1</sup>, University of Illinois at Chicago — Motivated by recent electron microscopy studies at the Si<sub>3</sub>N<sub>4</sub>/rare-earth oxide (REO) interfaces, we present first principles calculations for the preferred bonding sites and configurations of oxygen on various terminations of the  $\beta$ -Si<sub>3</sub>N<sub>4</sub> (10 $\bar{1}$ 0) surface as a function of coverage and surface stoichiometry. We predict that oxygen induces various surface reconstructions, and it has a strong tendency to replace N on the surface. The structural stability of most low-energy surfaces is driven by the tendency of Si to saturate its dangling bonds and of oxygen to bridge two Si atoms similar to the bonding in SiO<sub>2</sub>. The present *ab initio* results resolve the discrepancy between the experimental observations at the Si<sub>3</sub>N<sub>4</sub>/REO interfaces and previous theoretical studies<sup>2</sup> for bare surfaces regarding the lowest energy surface termination.

<sup>1</sup>Supported by NSF Grant No. DMR-0604964

<sup>2</sup>Juan C. Idrobo *et al.*, Phys. Rev. B **72**, 241301(R) (2005).

Serdar Ogut  
University of Illinois at Chicago

Date submitted: 27 Nov 2007

Electronic form version 1.4